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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Tzu-Chiang Sung

Serial No.: 10/614,462

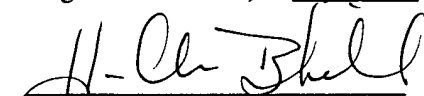
Filed: July 7, 2003

For: High Voltage Metal-Oxide Semiconductor
Device

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) Group Art Unit: 2813
)
) Examiner: Landau, Matthew C
)
) Confirmation No.: 7583
)
) TKHR Docket: 252011-1490
) Top-Team Dkt: 0503-9856US
)

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on July 8, 2005.


Signature – Hui Chin Barnhill

AMENDMENT AND RESPONSE TO NON-FINAL OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed May 31, 2005 has been carefully considered. In response thereto,

Applicants hereby submit the following amendments and remarks.